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02/26/03

501.40692X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): MIYAZAKI et al

Serial No.: 09/964,490

Filed: September 28, 2001

For: FABRICATION METHOD OF SEMICONDUCTOR  
INTEGRATED CIRCUIT DEVICE

Group: 2812

Examiner: Unassigned

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**INFORMATION DISCLOSURE STATEMENT  
UNDER 37 CFR 1.97 AND 1.98**

Assistant Commissioner for Patents  
Washington, D.C. 20231

February 20, 2003

Sir:

Pursuant to Applicants' duty of disclosure, enclosed please find copies of documents to be considered by the Examiner during examination of the above-identified application. Also enclosed are English translations of the respective documents. Further enclosed is a Form, substantially equivalent to Form PTO-1449, listing the enclosed documents.

This Information Disclosure Statement is being submitted prior to a first Office Action on the merits in the above-identified application. Accordingly, requirements of 37 CFR 1.97(b) are satisfied.

In any event, the following Statement is made under 37 CFR 1.97(e)(2):

No item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making reasonable inquiry, no item of information contained in this Information Disclosure Statement was known to any

individual designated in 37 CFR 1.56(c), more than three months prior to the filing of this Information Disclosure Statement.

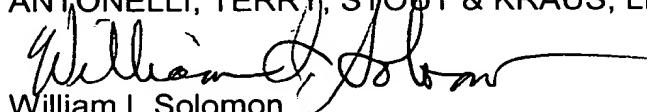
The documents, enclosed, listed on the enclosed Form, are not in English. For satisfying requirements of 37 CFR 1.98(a)(3), English translations of the listed documents are enclosed.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR 1.97 and 1.98 have been satisfied, in connection with the documents listed on the enclosed Form. Accordingly, consideration of the listed documents, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account No. 01-2135 (Case No. 501.40692X00), and please credit any excess fees to such Deposit Account.

Respectfully submitted,

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**FORM PTO-1449** U.S. Department of Commerce  
(Rev. 4/92) Patent and Trademark Office

ATTY. DOCKET NO.

501.40692X00

SERIAL NO.

09/964,490

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use several sheets if necessary)

APPLICANT

MIYAZAKI, et al.

FILING DATE

September 28, 2001

GROUP

2812

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO
5 6 3 0 1 2 9	3-26-81	Japan	G03F 1/00	H01L 21/30	X
5 9 2 2 0 5 0	2-4-84	Japan	G03F 1/02	H01L 21/30	X

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER

DATE CONSIDERED

**EXAMINER:** Initial if citation is considered, draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.